CONTENTS

CONTRIBUTORS xiii

FOREWORD xv

PREFACE xvii

LIST OF VOLUMES IN TREATISE xix

1. Work Function Measurements
by L. W. SWANSON AND P. R. DAVIS

1.1. Introduction 1

1.2. Work Function Theory 2

1.2.1. Basic Concepts 2

1.3. Electron Emission Methods 5

1.3.1. Thermionic Method 5
1.3.2. Photoelectric Emission 7
1.3.3. Field Electron Emission 8

1.4. Retarding-Potential Methods 11

1.4.1. The Shelton Triode 11
1.4.2. Electron-Beam Method 14
1.4.3. Field Emission Retarding-Potential Method 15

1.5. Capacitance Methods 17

1.5.1. The Kelvin–Zisman (Vibrating Capacitor) Method 17
1.5.2. Static Capacitor Methods 19

1.6. Comparison of the Various Measuring Techniques 19

1.7. Experimental Embodiments of the Various Techniques . . 21

1.8. The Future of Work Function Measurements 22

2. Vibrations in Overlayers
by W. HENRY WEINBERG

2.1. Introduction 23
2.2. Electron Energy Loss Spectroscopy 31
2.2.1. Introduction 31
2.2.2. Electron Energy Loss Spectrometers 33
2.2.3. Theoretical Considerations 46
2.2.4. Experimental Results: Dissociation of NO and Coadsorption of NO and CO on Ru(001) . . . 66
2.3. Reflection IR Spectroscopy 75
2.3.1. Introduction 75
2.3.2. Experimental IRAS 76
2.3.3. Theoretical Considerations 81
2.3.4. Experimental Results: The Adsorption of CO on Pd 84
2.4. Inelastic Electron Tunneling Spectroscopy 95
2.4.1. Introduction 95
2.4.2. Experimental Details 96
2.4.3. Theoretical Concepts 101
2.4.4. Experimental Results 103
2.5. Conclusions 113
2.5.1. Introduction 113
2.5.2. CO Chemisorption on Ru(001) 113
2.5.3. Tabulation of Previous EELS and IRAS Results . . 121
2.5.4. Update 124

3. Photoemission Spectroscopy of Valence States
by GIORGIO MARGARITONDO AND JOHN H. WEAVER

3.1. Introduction: Three-Step Model, Escape Depth, Relevant Parameters 127
3.1.1. Photoemission: A Versatile Probe of the Valence States 127

3.1.2. The Three-Step Model 129
3.1.3. Escape Depth 130
3.1.4. The Important Parameters. 132

3.2. Instrumentation. 133

3.2.1. Electron-Energy Analyzers. 134
3.2.2. Photon Sources 140

3.3. Conventional Photoemission 144

3.3.1. Density of States, Joint Density of States, and Energy Distribution of the Joint Density of States 145
3.3.2. Transition Probabilities 146
3.3.3. Interpreting the Energy-Distribution Curves . . . 147
3.3.4. Processes without **k** Conservation 148
3.3.5. Processing the Photoemission EDCs. 149
3.3.6. Experimental EDCs and Theoretical Curves: Bulk States 150
3.3.7. Surface-States Studies in the EDC Mode 152
3.3.8. Adsorption States 154

3.4. Polarized-Photon Photoemission 156

3.4.1. Photon-Polarization Selection Rules. 156
3.4.2. Experimental Problems in the Photon-Polarization Techniques. 158
3.4.3. Photon-Polarization Effects in Angle-Resolved Photoemission: The Hermanson Rule 159

3.5. Angle-Resolved Photoemission: The Band-Mapping Technique 161

3.5.1. The Surface Reciprocal-Lattice Vectors 162
3.5.2. Mahan Cones 163
3.5.3. Physical Information from the Angular Distribution of Photoelectrons 164
3.5.4. Band-Structure Mapping for Two-Dimensional Crystals 165
3.5.5. Band Structure of Adsorbed Overlayers 168
3.5.6. Three-Dimensional Band-Structure Mapping . . . 169

3.6. Synchrotron Radiation Techniques 171

3.6.1. Constant-Final-Energy-State Spectroscopy and Partial-Yield Spectroscopy 173

3.6.2. Constant-Initial-State Spectroscopy 177
3.7. Conclusions and Future Prospects 182
3.7.1. Future Prospects. 183

4. Core-Level Spectroscopies
by ROBERT L. PARK

4.1. Introduction 187
4.2. The Core-Level Structure of Atoms 188
4.2.1. Binding Energies. 189
4.2.2. Auger Yields and Lifetime Broadening. 190
4.3. The Interaction of Electrons with a Solid. 192
4.3.1. The Secondary-Electron Energy Distribution . . . 193
4.3.2. The Loss Spectrum. 195
4.3.3. The Emission Spectrum. 197
4.3.4. The Inelastic Scattering Mean Free Path 198
4.4. Appearance-Potential Spectroscopy 198
4.4.1. Core-Hole Excitation 199
4.4.2. Background Suppression 202
4.4.3. Resolution 205
4.4.4. Soft-X-Ray Appearance-Potential Spectroscopy . . 207
4.4.5. Auger Electron Appearance-Potential Spectroscopy 210
4.4.6. Disappearance-Potential Spectroscopy 213
4.5. X-Ray Photoelectron Spectroscopy 214
4.5.1. Core-Hole Excitation 215
4.5.2. Electron Spectroscopy 218
4.5.3. Chemical Shifts 223
4.6. Comparison of Binding Energy Measurements 225
4.7. Electron-Excited Auger Electron Spectroscopy 226
4.7.1. The Auger Transition Energies 227
4.7.2. The Auger Line Shape 230
4.7.3. AES and Surface Composition 231

4.8. Extended Fine Structure Analysis of Surfaces 232
4.8.1. Surface-Extended X-Ray Absorption Fine Structure 233
4.8.2. Extended Appearance-Potential Fine Structure . . 235

5. Diffraction Techniques
by MAX G. LAGALLY

5.1. Introduction 237
5.2. Elements of Diffraction Theory 240
5.2.1. Diffraction from Surfaces 242
5.2.2. Surface Defects 245
5.3. The Measurement of Diffracted-Intensity Distributions . . 258
5.3.1. Sensitivity 259
5.3.2. Resolving Power 260
5.4. Surface Crystallography Measurements 267
5.4.1. Diffraction Patterns 267
5.4.2. Equilibrium Position Determinations 268
5.4.3. Structural Defects 272
5.4.4. Thermodynamics and Kinetics 277
5.5. Instrumentation and Sample Preparation 280
5.5.1. Electron Guns. 281
5.5.2. Detectors 283
5.5.3. Goniometers 288
5.5.4. Sample Preparation 289
5.6. Representative Experimental Results 291
5.7. Conclusions 297

6. Ion Scattering and Secondary-Ion Mass Spectrometry
by W. HEILAND AND E. TAGLAUER

6.1. Ion Scattering Spectrometry 299
6.1.1. Fundamental Aspects. 299

6.1.2. Experiment 312
6.2. Secondary-Ion Mass Spectrometry 328
6.2.1. Fundamental Aspects 328
6.2.2. SIMS Experiments 337
6.3. Synopsis 347

7. High-Field Techniques
by J. A. PANITZ

7.1. Field-Electron-Emission Microscopy 349
7.1.1. The Fowler–Nordheim Equation 350
7.1.2. The Field-Electron-Emission Microscope 353
7.1.3. The Magnification of a Point-Projection Microscope 357
7.1.4. The Resolution of a Point-Projection Microscope . 358
7.1.5. Adsorption Studies Using the FEEM 359
7.1.6. Field Emission Energy Distributions 361
7.2. Applications of Field-Electron-Emission Microscopy . . . 363
7.2.1. Surface Diffusion 363
7.2.2. Sputtering, Nucleation, and Electron Sources . . . 366
7.2.3. Electrical Breakdown in High Vacuum 368
7.2.4. Molecular Imaging 370
7.2.5. Single-Atom Imaging 374
7.3. Field-Ion Microscopy 376
7.3.1. Field Ionization 378
7.3.2. Field-Ion Energy Distributions 380
7.3.3. The Hopping Gas Model 383
7.3.4. The Low-Temperature Field-Ion Microscope . . . 384
7.3.5. The Magnification of a Field-Ion Image 388
7.3.6. The Modern Field-Ion Microscope 389
7.3.7. Microchannel-Plate Image Intensification 390
7.3.8. Surface Diffusion Studies Using the FIM 392
7.4. Field Evaporation 397
7.5. Field-Ion Mass Spectroscopy 399
7.5.1. Field Ionization Sources 401

7.5.2. Liquid-Metal Field Desorption Sources 402

7.6. Atom-Probe Mass Spectroscopy 404

7.6.1. The Voltage-Pulsed Atom-Probe 404
7.6.2. The Pulsed-Laser Atom-Probe 406
7.6.3. Atom-Probe Measurements 407
7.6.4. First-Layer Composition 407
7.6.5. Composition of One Atomic Layer 408
7.6.6. Average Composition of the Near-Surface Region . 411

7.7. Field-Desorption Microscopy 412

7.7.1. The 10-cm Atom-Probe. 414
7.7.2. The Imaging Atom-Probe 414

7.8. Molecular Imaging with Ions 416

8. The Thermal Desorption of Adsorbed Species
by JOHN T. YATES, JR.

8.1. Introduction 425

8.2. Early Studies of Desorption from Polycrystalline Substrates 427

8.2.1. Introduction 427
8.2.2. Material Balance Equation for Thermal Desorption in a Vacuum System 430

8.3. Thermal Desorption from Single Crystals 431

8.3.1. Introduction 431
8.3.2. Preparation, Mounting, and Temperature Programming of Single Crystals 432
8.3.3. Isothermal Desorption Measurements 436
8.3.4. Isosteric Heat of Adsorption 438
8.3.5. Absolute Coverage Measurements. 441
8.3.6. Detectors for the Study of Thermal Desorption . . 444

8.4. Treatment of Experimental Desorption Data 447

8.4.1. Desorption Kinetics Using Gas Evolution Measurements (Constant Rate of Heating) 447
8.4.2. Desorption Kinetics Using Gas Evolution Measurements (Variable Rate of Heating) 449

8.4.3. Coverage Measurements Made during Programmed Desorption 451
8.4.4. Chemical Methods for Measuring Desorption Kinetics 453
8.5. Theories of Thermal Desorption 454
8.5.1. The Mobile Precursor Model in Adsorption and Desorption 454
8.5.2. Statistical Thermodynamics of Adsorption and Desorption 457
8.6. Concluding Remarks. 464

9. Experimental Methods in Electron- and Photon-Stimulated Desorption
by THEODORE E. MADEY AND ROGER STOCKBAUER

9.1. Theory and Mechanisms of Electron-Stimulated Desorption and the Relationship between ESD and PSD . 465
9.1.1. Experimental Observations 465
9.1.2. Mechanisms of Ion Formation and Desorption . . 467
9.2. Experimental Methods in ESD and PSD 473
9.2.1. Direct Detection of Desorbing Species 473
9.2.2. Evaluation of ESD and PSD Data: Cross Sections and Electron-Induced Surface Damage 498
9.2.3. Methods Based on Changes in Surface Properties: Detection of ESD and PSD Damage in Adsorbed Monolayers. 502
9.2.4. Measurements of Electron-Beam-Induced Damage in Thin Films and Bulk Samples 505
9.2.5. Electron-Stimulated Adsorption 511
9.3. Conclusions 513

AUTHOR INDEX 515
SUBJECT INDEX 531